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DATE: December 13, 2004
FILE NO: AMAT/5162/DISPLAY/AKT/RKK
TO: Examiner: Anna M. Crowell
FAX NO: 703-872-9306
COMPANY: USPTO
FROM: Keith M. Tackett
PAGE(S) with cover: 4
ORIGINAL TO FOLLOW? ☐ YES ☒ NO

PETITION FOR 1-MONTH EXTENSION OF TIME; AND (COPY OF UTILITY PATENT APPLICATION TRANSMITTAL)

TITLE: Full Glass Substrate Deposition in Plasma Enhanced Chemical Vapor Deposition
U.S. SERIAL NO.: 10/024,985
FILING DATE: December 18, 2001
INVENTOR: Shang, et al.
EXAMINER: Anna M. Crowell
GROUP ART UNIT: 1763
CONFIRMATION NO.: 4811

CONFIDENTIALITY NOTE

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PATENT
Asy. Dir. AMAT/5162/DISPLAY/AKT/TKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Shang, et al.

Serial No.: 10/024,985

Confirmation No.: 4811

Filed: December 18, 2001

For: Full Glass Substrate
Deposition in Plasma
Enhanced Chemical Vapor
Deposition

Group Art Unit: 1763

Examiner: Anna M. Crowell

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR 1.8	
I hereby certify that this correspondence and the documents referred to as attached therein are being facsimile transmitted to the U.S. Patent and Trademark Office to the fax number indicated by the Examiner, namely, fax number (703) 872-9306 to the attention of the named Examiner, on the date below.	
12/13/04 Date	<i>Keith M. Tackett</i> Signature

PETITION FOR ONE-MONTH EXTENSION OF TIME

Applicant respectfully petitions the Commissioner under 37 CFR 1.136(a) to grant a one-month extension of time to and including December 13, 2004, in which to file the Continuation Application (copy coversheet attached).


This form is filed in duplicate. The Commissioner is authorized to charge the fee of \$120.00 and any additional fees which may be required for this submission to Deposit Account No. 20-0782/5162/KMT.

Respectfully submitted,

Keith M. Tackett

Keith M. Tackett
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Please type a plus sign (+) inside this box → Approved for use through 07/31/2006. OMB 0551-0032
U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

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**UTILITY
PATENT APPLICATION
TRANSMITTAL**

(Only for new nonprovisional applications under 37 C.F.R. 1.53(b))

Attorney Docket No.	AMAT/5182.C1/DISPLAY/AKT/RKK
First Inventor	QUANYUAN SHANG, ET AL
Title	FULL CLASS SUBSTRATE DEPOSITION PLASMA ENHANCED CHEMICAL VAPOR DEPOSITION
Express Mail Label No.	EV331233875US

APPLICATION ELEMENTS

See MPEP chapter 600 concerning utility patent application contents.

ADDRESS TO:Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

1. ☐ Fee Transmittal Form (e.g., PTO/SB/17)
(Submit an original and a duplicate for fee processing)
2. ☐ Applicant claims small entity status.
See 37 CFR 1.27.
3. ☒ Specification [Total Pages 18]
(preferred arrangement set forth below)
 - Descriptive title of the invention
 - Cross Reference to Related Applications
 - Statement Regarding Fed sponsored R & D
 - Reference to sequence listing, a table, or a computer program listing appendix
 - Background of the invention
 - Brief Summary of the invention
 - Brief Description of the Drawings (if filed)
 - Detailed Description
 - Claim(s)
 - Abstract of the Disclosure
4. ☒ Drawing(s) (35 U.S.C. 113) [Total Sheets 5]
[Total Pages 1]
5. Oath or Declaration [Total Pages 1]
 - a. ☐ Newly executed (original or copy)
 - b. ☐ Copy from a prior application (37 CFR 1.63 (d))
(for a continuation/divisional with Box 18 completed)
6. ☐ Application Data Sheet. See 37 CFR 1.76

7. ☐ CD-ROM or CD-R in duplicate, large table or Computer Program (Appendix)
8. Nucleotide and/or Amino Acid Sequence Submission (if applicable, all necessary)
 - a. ☐ Computer Readable Form (CRF)
 - b. Specification Sequence Listing on:
 - i. ☐ CD-ROM or CD-R (2 copies); or
 - ii. ☐ paper
 - c. ☐ Statements verifying identity of above copies

ACCOMPANYING APPLICATIONS PARTS

9. ☐ Assignment Papers (cover sheet & document(s))
10. ☐ 37 C.F.R. §3.73(b) Statement of Power of Attorney (when there is an assignee)
11. ☐ English Translation Document (if applicable)
12. ☐ Information Disclosure Statement (IDS)/PTO-1449 [Copies of IDS Citations]
13. ☐ Preliminary Amendment
14. ☒ Return Receipt Postcard (MPEP 503)
(Should be specifically itemized)
15. ☐ Certified Copy of Priority Document(s)
(if foreign priority is claimed)
16. ☐ Nonpublication Request under 35 U.S.C. 122 (b)(2)(B)(i). Applicant must attach form PTO/SB/35 or its equivalent.
17. ☐ Other: _____

18. If a CONTINUING APPLICATION, check appropriate box, and supply the requisite information below and in a preliminary amendment, or in an Application Data Sheet under 37 CFR 1.78:

☒ Continuation ☐ Divisional ☐ Continuation-in-part (CIP)

of prior application No: 10/ 024,985

Prior application information:

Examiner Anna M. Crowell

Group / Art Unit: 1763

For CONTINUATION or DIVISIONAL APPS only: The entire disclosure of the prior application, from which an oath or declaration is supplied under Box 5b, is considered a part of the disclosure of the accompanying or divisional application and is hereby incorporated by reference. The incorporation can only be relied upon when a portion has been inadvertently omitted from the submitted application parts.

19. CORRESPONDENCE ADDRESS☒ Customer Number or Bar Code Label

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or ☐ Correspondence address below

(Insert Customer No. or Attach bar code label here)

Name	Moser, Patterson & Sheridan, LLP.				
Address	Applied Materials, Inc. 3040 Post Oak Boulevard, Suite 1500				
City	Houston	State	TX	Zip Code	77056
Country	USA	Telephone	713-623-4844	Fax	713-623-4846

Name (Print/Type)	Keith M. Tackett	Registration No. (Attorney/Agent)	32,008
Signature		Date	December 13, 2004

This collection of information is required by 37 CFR 1.53(b). The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 12 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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